Notice of Allowability	Application No.	Applicant(s)	
	10/602,943	RODRIGUEZ ET AL.	
	Examiner	Art Unit	
	Hsien-Ming Lee	2823	
The MAILING DATE of this communication apperation apperation allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RI of the Office or upon petition by the applicant. See 37 CFR 1.313	(OR REMAINS) CLOSED in this app or other appropriate communication IGHTS. This application is subject to	olication. If not included will be mailed in due course. THIS	
1. This communication is responsive to <u>5/24/04</u> .			
2. The allowed claim(s) is/are <u>1-23</u> .			
3. \boxtimes The drawings filed on <u>24 June 2003</u> are accepted by the E.	xaminer.		
 4. Acknowledgment is made of a claim for foreign priority una a) All b) Some* c) None of the: Certified copies of the priority documents have Certified copies of the priority documents have Copies of the certified copies of the priority documents have Copies of the certified copies of the priority documents have Copies of the certified copies of the priority documents have Certified copies of the certified copies of the priority documents have * Certified copies not received: Applicant has THREE MONTHS FROM THE "MAILING DATE" noted below. Failure to timely comply will result in ABANDONM 	been received. been received in Application No cuments have been received in this of	national stage application from the	
 THIS THREE-MONTH PERIOD IS NOT EXTENDABLE. 5. A SUBSTITUTE OATH OR DECLARATION must be subm INFORMAL PATENT APPLICATION (PTO-152) which give 	itted. Note the attached EXAMINER' es reason(s) why the oath or declara	S AMENDMENT or NOTICE OF tion is deficient.	
6. CORRECTED DRAWINGS (as "replacement sheets") mus			
(a) ☐ including changes required by the Notice of Draftspers		948) attached	
1) hereto or 2) to Paper No./Mail Date		C. C	
(b) ☐ including changes required by the attached Examiner's Paper No./Mail Date	s Amenament / Comment or in the C	office action of	
Identifying indicia such as the application number (see 37 CFR 1, each sheet. Replacement sheet(s) should be labeled as such in t	.84(c)) should be written on the drawir he header according to 37 CFR 1.121(c	igs in the front (not the back) of i).	
7. DEPOSIT OF and/or INFORMATION about the deposit attached Examiner's comment regarding REQUIREMENT			
Attachment(s)			
1. Notice of References Cited (PTO-892)	5. Notice of Informal P	atent Application (PTO-152)	
2. Notice of Draftperson's Patent Drawing Review (PTO-948)		6. Interview Summary (PTO-413),	
3. Information Disclosure Statements (PTO-1449 or PTO/SB/0 Paper No./Mail Date		Paper No./Mail Date 7. ⊠ Examiner's Amendment/Comment	
4. Examiner's Comment Regarding Requirement for Deposit	_	ent of Reasons for Allowance	
of Biological Material	9. Other		
	HSIEN-MING LEE PRIMARY EXAMINED	Hsien-Ming Lee Primary Examiner Art Unit: 2823	

U.S. Patent and Trademark Office PTOL-37 (Rev. 1-04)

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DETAILED ACTION

Remarks

1. The objection to claim 2 and the rejections to claims 1-23 are withdrawn in response to applicants' amendment and arguments filed 5/24/2004. Claims 1-23 are pending in the application.

Examiner's Amendment

2. An examiner's amendment to the record appears below. Should the changes and/or additions be unacceptable to applicant, an amendment may be filed as provided by 37 CFR 1.312. To ensure consideration of such an amendment, it MUST be submitted no later than the payment of the issue fee.

Authorization for this examiner's amendment was given in a telephone interview with Thomas G. Eschweiler (Reg. No. 36,981) on July 27, 2004.

3. The application has been amended as follows:

In claim 17, at line 7, replace "selecting one or more bake parameters" with -- selecting a bake parameter -; and at line 10, replace "one or more bake parameters" with - bake parameter --. (Emphasis added)

In re claim 20, at line 2, delete "one or more" after "selecting."

Allowable Subject Matter

- 4. Claims 1-23 are allowed.
- 5. The following is an examiner's statement of reasons for allowance:

Applicant's arguments against Traynor to US 6,008,659 is persuasive. Traynor teaches a test method for characterizing same state and opposite state retention performance over time in

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ferroelectric capacitors. Traynor, however, at least fails to teach or suggest selecting a time parameter and a temperature parameter according to a data retention lifetime and selecting a particular initial state according to the data retention lifetime (in re claim 1); selecting a bake parameter according to the desired data retention lifetime and the tested data retention lifetime and baking the device according to the bake parameter (in re claim 17) and adjusting the process time and the process temperature according to the obtained tested data retention lifetime and a suitable data retention lifetime (in re claim 20).

In addition, the combination of Traynor, Kammerdiner et al. (US 5,969,935) and Mitra et al. (US 5,661,730) do not read the claims. Therefore, the instant invention is neither anticipated nor rendered obvious over the prior art of record.

- 6. Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."
- 7. Any inquiry concerning this communication or earlier communications from the examiner should be directed to Hsien-Ming Lee whose telephone number is 571-272-1863. The examiner can normally be reached on Tuesday-Thursday (8:00 \sim 6:30).

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Olik Chaudhuri can be reached on 571-272-1855. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

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Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Hsien-Ming Lee Primary Examiner Art Unit 2823

July 27, 2004

HSIEN-MING LEE
PRIMARY EXAMINED The form